

11-04-02 3739

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as Express Mail, Airbill No. EU186313828US, in an envelope addressed to: Box Non-Fee Amendment, Commissioner for Patents, Washington, DC 20231, on the date shown below.

Dated: November 1, 2002

Signature: *Ava Brown*

(Ava Brown)

Docket No.: HO-P02540US1

Docket No.: HO-P02540US1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Gordon S. Scholler, et al.

Application No.: 09/896,429

Group Art Unit: 3739

Filed: June 29, 2001

Examiner: A. Farah

For: **IMPROVED APPLANATION LENS AND  
METHOD FOR OPHTHALMIC SURGICAL  
APPLICATIONS**

**TRANSMITTAL LETTER**

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

Enclosed are the following items for filing in connection with the above-referenced Patent Application:

1. Amendment in Response to Non-Final Office Action.

The Commissioner is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 06-2375, under Order No. HO-P02540US1. A duplicate copy of this paper is enclosed.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 06-2375, under Order No. HO-P02540US1 from which the undersigned is authorized to draw.

Dated: November 1, 2002

Respectfully submitted,

By Jayne C. Plana

Jayne C. Plana

Registration No.: 48,424

FULBRIGHT & JAWORSKI L.L.P.

1301 McKinney, Suite 5100

Houston, Texas 77010-3095

(713) 651-5151

Attorneys for Applicant

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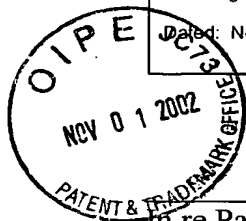
Dated: November 1, 2002

Signature: *Ava R. Brown*

(Ava R. Brown)

Docket No.: HO-P02540US1  
(PATENT)

9/A  
DL  
11-13-02



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Scholler, Gordon S., et al.

Application No.: 09/896,429

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For: IMPROVED APPLANATION LENS AND  
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RECEIVED

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TECHNOLOGY CENTER R3700

RESPONSE TO OFFICE ACTION MAILED AUGUST 1, 2002

Box Non-Fee Amendment  
Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In response to the Office Action mailed August 1, 2002 (Paper No. 6), please amend the above-identified U.S. patent application as set forth below:

In the Abstract

In the abstract, please substitute the following paragraph for paragraphs 103-04:

*base of the lens*  
*where*  
A1 { An improved appplanation lens and method for use in an interface between a patient's eye and a surgical laser system does not discolor or lose light transmittance when subjected to gamma radiation. The improved appplanation lens has an appplanation surface configured to contact the eye upon application of a pressure. The lens is formed of high purity silicon dioxide (SiO<sub>2</sub>) with purity great enough to resist discoloration upon prolonged irradiation by high-energy radiation such as UV, x-rays, gamma rays or neutrons, and is preferably a fused silica.